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Applicant : Jeffrey Drue David
Serial No. : 10/643,583
Filed : August 18, 2003

Art Unit : 3723
Examiner : Maurina T. Rachuba


Title : PLATEN AND HEAD ROTATION RATES FOR MONITORING CHEMICAL
MECHANICAL POLISHING

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Attached to this facsimile communication cover sheet is Amendment After Allowance
Pursuant to 37 C.F.R. §1.312 and Comments on Statement of Reasons for Allowance, faxed this
12th day of October, 2005, to the United States Patent and Trademark Office.

Respectfully submitted,

Date: October 12, 2005


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